

Notice of References Cited	Application/Control No. 10/622,029	Applicant(s)/Patent Under Reexamination TAKIZAWA ET AL.	
	Examiner Chau Nguyen	Art Unit 2176	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,678,867	01-2004	Fong et al.	715/523
*	B	US-2003/0140316	07-2003	Lakritz, David	715/536
	C	US-			
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	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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